



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yukie NAKANO et al.

Group Art Unit: 2831

Application No.: 09/865,575

Examiner: Eric W. Thomas

Filed: May 29, 2001

Docket No.: 109639

For: MULTILAYER CERAMIC CAPACITOR AND PRODUCTION METHOD THEREOF

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination and entry and consideration of the December 2, 2002 Amendment After Final Rejection submission. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 138514 in the amount of ☒ \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Director is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Richard J. Kim
Registration No. 48,360

JAO:RJK/mdw

Date: January 29, 2003

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

01/30/2003 WABDELRI 00000037 09865575

01 FC:1801

750.00 DP

#14/RCE
DENIALS
2-5-03

RECEIVED
FEB -3 2003
TECHNICAL CENTER 2800